

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use several sheets if necessary) (PTO-1449)	PATENT DOCKET NO. 176/60930		SERIAL NO. 09/759,913
	APPLICANT David P. Biss, Thomas G. Brown, and Kathleen S. Youngworth		
	FILING DATE January 12, 2001		GROUP ART UNIT 2873

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPRO- PRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRAN- SLATION IF APPRO- PRIATE

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

RDS		1	R. D. Allen et al., "The Zeiss-Nomarski Differential Interference Equipment For Transmitted Light Microscopy,"
			Z. wiss. Mikroskopie, 69:193-221 (1969).
RDS		2	E. Slayter, "The Interference Microscope," <u>Optical Methods in Biology</u> , Chapter 14., New York:John Wiley & Sons,
			page 303 (1970).
RDS		3	E. Slayter, "The Polarizing Microscope," <u>Optical Methods in Biology</u> , Chapter 15, New York:John Wiley & Sons,
			pp. 318-340 (1970).
RDS		4	D. Pohl, "Operation Of A Ruby Laser In The Purely Transverse Electric Mode TE ₀₁ ," <u>Appl. Phys. Lett.</u> , 20:266-267
			(1972).
RDS		5	J. J. Wynne, "Generation Of the Rotationally Symmetric TE ₀₁ and TM ₀₁ Modes From A Wavelength-Tunable Laser,"
			<u>IEEE J. Quant. Elec.</u> , QE-10:125-127 (1974).
RDS		6	M. E. Marhic et al., "Low-Order TE _{0q} Operation Of A CO ₂ Laser For Transmission Through Circular Metallic
			Waveguides," <u>Appl. Phys. Lett.</u> , 38:743-745 (1981).
RDS		7	R. Yamaguchi et al., "Liquid-Crystal Polarizers With Axially Symmetrical Properties," <u>Japanese Journal of Applied</u>
			<u>Physics</u> , 28:1730-1731 (1989).

EXAMINER

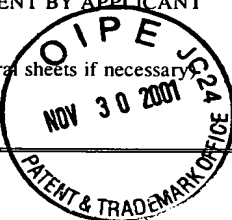
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RNS	8	C. J. Cogswell et al., "Confocal Brightfield Imaging Techniques," T. Wilson, <u>Confocal Microscopy</u> , London:Academic Press Limited, Chapter 8, page 229 (1990).
RNS	9	S. C. Tidwell et al., "Generating Radially Polarized Beams Interferometrically," <u>Applied Optics</u> , 29:2234-2239 (1990).
RNS	10	T. Erdogan et al., "Circularly Symmetrical Operation Of A Concentric-Circle-Grating, Surface-Emitting, AlGaAs/GaAs Quantum-Well Semiconductor-Laser," <u>Appl. Phys. Lett.</u> , 60:1921-1923 (1992).
RNS	11	E. G. Churin et al., "Polarization Configurations With Singular Point Formed By Computer-Generated Holograms," <u>Optics Communications</u> , 99:13-17 (1993).
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RNS	13	R. H. Jordan et al., "Free-Space Azimuthal Paraxial Wave Equation: The Azimuthal Bessel-Gauss Beam Solution," <u>Optics Letters</u> , 19:427-429 (1994).
RNS	14	D. G. Hall, "Vector-Beam Solutions Of Maxwell's Wave Equation," <u>Optics Letters</u> , 21:9-11 (1996).
RNS	15	P. L. Greene et al., "Diffraction Characteristics Of The Azimuthal Bessel-Gauss Beam," <u>J. Opt. Soc. Am. A</u> , 13:962-966 (1996).
RNS	16	M. Stalder et al., "Linearly Polarized Light With Axial Symmetry Generated By Liquid-Crystal Polarization Converters," <u>Optics Letters</u> , 21:1948-1950 (1996).

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